The rapid formation of functional monolayers on silicon under mild conditions†

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We report on an exceedingly mild chemical functionalization of hydrogen-terminated Si(100) with unactivated and unprotected bifunctional α,ω-dialkyne. Monolayer formation occurs rapidly in the dark, and at room temperature, from dilute solutions of an aromatic-conjugated acetylene. The method addresses the poor reactivity of p-type substrates under mild conditions. We suggest the importance of several factors, including an optimal orientation for electron transfer between the adsorbate and the Si surface, conjugation of the acetylenic function with a π-system, as well as the choice of a solvent system that favors electron transfer and screens Coulombic interactions between surface holes and electrons. The passivated Si(100) electrode is amenable to further functionalization and shown to be a viable model system for redox studies at non-oxide semiconductor electrodes in aqueous solutions.

1. Introduction

Silicon-organic monolayer systems are arguably one of the most viable platforms for the development of sensing and molecular electronic devices. 1–4 Most recent advances in this field have been driven by an improved understanding of the reactivity of the silicon hydride surface (Si–H) toward nucleophilic organic molecules under either thermal conditions 5 or visible/UV light irradiation. 6–9 It is now apparent that multiple mechanisms may coexist and that seemingly insignificant experimental factors may well dictate a preferred reaction pathway.9 For instance solvent molecules and the reaction vessel have a far from passive role, 9,10 redox impurities or aromatic additives can dictate the reaction kinetics 5,6 as can the available energy levels of the adsorbate. 11

While the mechanistic picture remains particularly complex and debated,12,13 it is now clear that (i) nucleophilic attack by 1-alkynes on surface holes is the prime candidate for rapid monolayer formation, 7,14,15 (ii) impurities with sufficiently high electron affinity can participate at the interface in electron-transfer (ET) events that facilitate monolayer grafting, 5,6 and (iii) band-bending effects in the semiconductor can greatly influence the grafting efficiency, 6,16 with monolayer grafting being greatly favored on n-type substrates. The presence of an aromatic ring in the adsorbate molecule has very recently started to appear as an additional variable, possibly ensuring a sufficiently long residence time of the adsorbate at the Si surface coupled with the molecule having an optimal orientation and distance for efficient charge transfer with the substrate.8,17 All these observations provide key guidelines when trying to optimize the preparation of Si–C-bound films at Si–H surfaces.

Consistent with experimental data, when ruling out a reaction pathway involving multiple species,11,12,18 energetic considerations alone deem the hydrolysilylation of 1-alkenes at room temperature without light excitation as an unlikely event. Interestingly, this

Scheme 1 Dark hydrosilylation of an aromatic-conjugated acetylene (DEB) at room temperature and CuAAC “click” derivatization of the functional monolayer.
appears not to be the case for 1-alkyne adsorbates. For neat samples of unactivated 1-alkynes (methyl-terminated film) reaction times for dark and uncatalyzed reaction are exceedingly long (~24 h), even on n-type materials where band-bending considerations are likely to favor migration of electrophilic holes toward the surface. A major technological challenge is in reducing dark reaction times to the order of minutes while producing high-quality functional films from dilute solutions of an adsorbate of interest, and doing so through mild synthetic strategies that have little or no dependency on substrate doping/banding and that do not require the use of additives.

The purpose of this work is to address these issues by defining the experimental factors that can be used to both reduce reaction times for hydrosilylation reactions carried out at room temperature and without light excitation as well as to overwrite the generally-observed higher reactivity of n-type materials. The key to this work is the combination of a molecular adsorbate, 1,4-diethynylbenzene (DEB), which is expected to both stabilize Si-centered cations and to favorably orient on the Si–H surface for optimal electron transfer, with a solvent system that can facilitate electron transfer and screen Coulomb interactions between surface holes and electrons.

2. Experimental section

2.1 Materials

Hydrogen peroxide (30 wt% sol. in water, Sigma-Aldrich), hydrofluoric acid (Riedel-de Haën, 48 wt% sol. in water), and sulfuric acid (J. T. Baker) used in wafer cleaning and etching procedures were of semiconductor grade. 1,4-Diethynylbenzene (DEB, Aldrich, 96%) was purified by silica gel column chromatography, eluting with hexane. 1,8-Nonadynne (Alfa Aesar, 97%) was redistilled from sodium borohydride (Sigma-Aldrich, 99+%), under reduced pressure (80 °C, 10–12 Torr) and stored under a high purity argon atmosphere (O2 < 5 ppb) prior to use. Azidomethylferrocene was prepared according to literature procedures.

2.2 Surface analysis

2.2.1 XPS measurements. X-ray photoelectron spectra were obtained on an ESCALAB 220iXL spectrometer fitted with a monochromatic Al Kz source (1486.6 eV), a hemispherical analyzer and a 6 channel detector. High resolution spectra of Si 2p (93–109 eV binding energy), C 1s (279–295 eV), N 1s (392–408 eV), O 1s (525–541 eV), F 1s (677–694 eV), and Fe 2p (700–735 eV), as well as survey scans (0–1300 eV) were recorded in normal emission (θ = 90°) with the analyzing chamber operating below 10−9 mbar. The atomic compositions were corrected for atomic sensitivities and measured from high-resolution scans. Atomic sensitivity factors are often instrument-sensitive and so the atomic sensitivities obtained from the Avantage software interfaced with the spectrometer were 0.817 for Si 2p, 1.000 for C 1s, 1.800 for N 1s, 2.930 for O 1s, 4.430 for F 1s, and 16.420 for Fe 2p. The resolution of the spectrometer is ca. 0.6 eV as measured from the Ag 3d5/2 signal (full width at half maximum, 6.880) with 20 eV pass energy. High-resolution scans were run with a 0.1 eV step size, a dwell time of 100 ms and the analyzer pass energy set to 20 eV. Survey scans were carried out with a 1.0 eV step size, a 100 ms dwell time and an analyzer pass energy of 100 eV. After background subtraction using the Shirley routine, spectra were fitted with Voigt functions (a convolution of Lorentzian and Gaussian profiles) as described previously. All energies are binding energies expressed in eV, obtained by applying to all samples a rigid shift to bring the binding energy of the C 1s peak to a value of 285.0 eV. The ratios of the integrated areas for the refined C 1s (C–C, carbon-bonded carbons) and N 1s emissions, each normalized for their elemental sensitivity, scanning time (number of scans accumulated), and for a square root dependence on the photoelectron kinetic energy, afforded an estimate of the conversion of the acetylenyl surface (DEB film) to the ferrocene-functionalized surface. When detectable above noise levels, the fractional monolayer coverage of oxidized silicon was calculated directly from the oxidized-to-bulk Si 2p peak area ratio according to the method described by Webb and co-workers for very thin oxide overlayers. The spectrometer silica detection limit can be approximated to ca. 0.06 monolayer equivalents.

2.2.2 X-ray reflectometry. X-ray reflectivity (XRR) profiles of the self-assembled surfaces were measured under ambient conditions on a Panalytical Ltd X’Pert Pro Reflectometer using Cu Kz X-ray radiation (λ = 1.54056 Å). The X-ray beam was focused using a Göbel mirror and collimated with 0.2 mm pre-sample slit and a post-sample parallel plate collimator. Reflectivity data were collected over the angular range 0.05° ≤ θ ≤ 5.00°, with a step size of 0.010° and counting times of 10 s per step. Prior to measurements, samples were stored under argon and exposed to air for approximately 10 min in order to be aligned on the reflectometer. From the experimental data, structural parameters of the self-assembled structures were refined using the MOTOFIT analysis software with reflectivity data presented as a function of the momentum transfer vector normal to the surface Q = 4π(sin θ)/λ. The Levenberg–Marquardt method was used to minimize χ² values in the fitting routines.

2.2.3 Spectroscopic ellipsometry. Ellipsometric spectra were recorded using a variable angle spectroscopic ellipsometer (M-2000X-210, J. A. Woollam Co., Inc., USA) at three different angles of incidence (65°, 70°, and 75° to the surface normal) over the 250–1000 nm wavelength range (4.96–1.24 eV). The values of refractive index (n) and imaginary refractive index (k)
for bare (i.e., Si–H) phosphorous- and boron-doped reference substrates were taken before analysis. Acquired data on the changes in light polarization at the air/monolayer/substrate interfaces were modelled using the Cauchy approximation in the WVASE 32\textsuperscript{®} software package, and were used to extract monolayer thickness values. Measurements of at least four different points on each surface were carried out and were found to be within 1 Å of the reported average. The sample-to-sample reproducibility was within 2 Å.

2.2.4 Electrochemical characterization. Electrochemical experiments were performed in a PTFE three-electrode cell with the modified silicon surface as the working electrode, a platinum mesh (ca. 1200 mm\textsuperscript{2}) as the counter electrode, and Ag/AgCl in 3 M NaCl as the reference electrode. All potentials are reported versus the reference electrode. A rectilinear cross-section Viton\textsuperscript{®} gasket defined the geometric area of the working electrode to 24.6 mm\textsuperscript{2}. The bulk of the backside of the silicon sample was exposed with emery paper and rubbed with gallium indium eutectic. A planar copper electrode pressed onto the backside of the sample served as an ohmic contact. The cell was enclosed in a grounded Faraday cage during all measurements. Cyclic voltammetry (CV) measurements were performed using a BAS 100B electrochemical analyzer (Bioanalytical Systems, Inc., W. Lafayette, IN). Electrochemical impedance measurements (EIS) were performed using a Solartron 1255B (Farnborough, UK) frequency response analyzer interfaced to a Solartron 1287 potentiostat/galvanostat module. Impedance data were collected at 60 frequencies in the frequency range of 0.01 Hz to 0.1 MHz. An ac potential amplitude of 15 mV root mean square was added to the dc potential (\(E_\text{dc}\)) of the working electrode. EIS measurements for ferrocenyl films were performed in aqueous perchlorate-based electrolytes. Both the in-phase (\(Z'\)) and out-of-phase impedance (\(Z''\)) were extracted at the same time from the data and analyzed using the ZView 3.1 and ZPlot software (Scribner Associates, Inc.). The formalism developed by Lavoron was used to obtain kinetic information,\textsuperscript{24} namely the apparent electron-transfer rate constant, \(k_\text{et}^{\circ}\), for the electron-transfer process between tethered redox groups and the conducting substrate. Impedance data are interpreted by fitting the data to equivalent circuit models using the complex nonlinear least squares technique included in the frequency-response analysis software. All electrochemical experiments were performed at room temperature (23 ± 2 °C) in air.

2.3 Surface modification

2.3.1 Grafting of 1,4-diethynylbenzene on Si(100)–H. Silicon wafers were cut into pieces (approx. 30 × 10 mm), which were cleaned in a 3 : 1 solution of concentrated sulfuric acid and 30% hydrogen peroxide for 30 min at 100 °C (CAUTION: this is a strong oxidant and reacts violently with organic substances). After cleaning and extensive water rinsing, the silicon chips were etched for 1.5 min in 2.5% aqueous hydrofluoric acid solution. The rough side of the single-side polished silicon wafer behaves as a sacrificial anode providing cathodic protection for the polished face.\textsuperscript{25} This etching condition is known to create a mainly dihydride surface.\textsuperscript{26} Samples were subsequently transferred to a Pyrex reaction tube. The tube was sealed with a rubber septum and kept under a stream of argon (\(\text{H}_2\text{O} < 10 \text{ ppb}, \text{O}_2 < 5 \text{ ppb}\)). An Ar-purged (\(>15\) min) 5 mM solution of DEB in either dichloromethane, tetrahydrofuran or acetonitrile was introduced into the bottle via cannulation. Control experiments with 1,8-nonadiyne were performed in acetonitrile only. Reactions were carried out at room temperature and in the dark. The reaction vessel was then opened to the atmosphere, and the functionalized surface samples were rinsed several times with dichloromethane and rested for a 12 h period in a sealed vial under dichloromethane in argon at +4 °C, before being either analyzed or further reacted with azidomethylferrocene.

2.3.2 CuAAC attachment of azidomethylferrocene onto the acetylenyl surface. To a reaction vial containing the alkyne-functionalized silicon surface were added (i) azidomethylferrocene (10 mM, 2-propanol/water, 2 : 1), (ii) copper(II) sulfate pentahydrate (0.8 mol% relative to the azide) and (iii) sodium ascorbate (80 mol% relative to the azide). Reactions were carried out in air, at room temperature under ambient light and stopped after 15 min by removal of the samples from the reaction vessel. The prepared surface-bound \([1,2,3]\)-triazoles were rinsed consecutively with copious amounts of water and ethanol, and then rested at room temperature for a 1 min period in a 0.5 M hydrochloric acid solution. Samples were then rinsed with copious amounts of water and ethanol before being analyzed.

3. Results and discussion

We first sought to explore the reaction of 1,4-diethynylbenzene (DEB) with hydrogen terminated silicon surfaces as a simple approach to allow further modification of silicon surfaces \(\text{via}\) CuAAC\textsuperscript{27} “click” reactions. Our first attempts at this were performed with DEB dissolved in acetonitrile. To our surprise the reaction appeared to proceed rapidly in the dark and without elevated temperature on both n- and p-type silicon.

Ellipsometry (Fig. 1a), XPS (Fig. 1b, Fig. S4 and S5, ESI\textsuperscript{†}) and XRR data (Fig. 2, and Fig. S6, ESI\textsuperscript{†}) imply that monolayer formation at room temperature and without illumination is very rapid if DEB is dissolved in acetonitrile. Following a 180 min reaction, values of monolayer thickness, as obtained from spectroscopic ellipsometry, X-ray reflectometry and XPS\textsuperscript{30} data are in good agreement with the computed\textsuperscript{31} value of 0.9 nm for a monolayer of DEB molecules standing normal to the surface. From the refined atomic composition data derived from XPS, by using the model of Cicero \textit{et al.},\textsuperscript{32} it is possible to calculate the fractional surface coverage of surface silicon atoms by DEB molecules in the monolayer (ML).\textsuperscript{33} Upon a reaction time of 180 min on n- and p-Si(100) the estimated values of surface coverage of DEB molecules to surface silicon atoms are 0.46 and 0.42, respectively; data indicating a densely packed monolayer.\textsuperscript{34} Notably, at a reaction time of only 10 min, the fractional coverage value is already significant; being close to 0.26 on n-type and 0.23 on p-type surfaces, with an estimated film thickness of ca. 0.5 nm. It is these unexpected observations that...
motivated us to explore the reaction further, with particular attention to the role of solvent.

The solvent and/or solute electron scavenging ability is expected to be important as it can influence electron–hole recombination events. Hence, solvents that reduce electron–hole recombination may favor the reaction of unsaturated nucleophilic molecules with surface-localized holes. It was therefore even more surprising to observe a total lack of reactivity when DEB grafting was attempted from a 5 mM solution in dichloromethane (DCM). DCM is a mild oxidizer (redox potential is $-1.1$ V vs. SCE in acetonitrile) of low nucleophilicity and low dielectric constant ($\varepsilon_{\text{DCM}} = 8.9$). Halocarbons have good electron-accepting properties, and because the energy of a conduction band electron ($ca. -3.5$ eV) exceeds that of the solvent LUMO, the halocarbon solvent should be effective in trapping electrons, thus reducing recombination events and favoring reactions of surface holes with the nucleophilic DEB molecule.

The lack of reactivity of the DEB/DCM system (Fig. 1 and Fig. S1–S3, ESI†) would suggest that at room temperature, and without illumination of the Si sample, the electron-scavenging ability of the solvent alone does not suffice to bring about monolayer formation in the time scale of the experiment. A solvent like acetonitrile, a poor oxidizer (electron affinity, EA is $ca. -2.84$ eV) but with a high dielectric constant ($\varepsilon_{\text{acetonitrile}} = 37.5$), should afford an environment more favorable for electron transfer (ET), in this case putatively from the Si conduction band to the LUMO of DEB. Solvated electrons and solvent anions can coexist in liquid acetonitrile, and the higher dielectric constant could account, at least to a degree (vide infra), for the appreciable rate-enhancing effect compared to halocarbon solvents. Electron affinity values, or rate constants for their reaction with hydrated electrons, are unfortunately not known for both DEB and for its close relative, phenylacetylene. A comparison with benzene would be of limited relevance as in this limit case the energy gain by adding an extra electron is exceedingly low (electron affinity for benzene is $ca. -0.72$ eV and the redox potential is as low as $-3.4$ V vs. SCE). An interesting and relevant parallel can however be drawn with styrene. In this case it is possible to put forward a case for electron-trapping by this aromatic-conjugated olefin. The second-order rate constant for the trapping of styrene by solvated electrons generated by pulsed radiolysis is $3.9 \times 10^{10} \text{ M}^{-1} \text{ s}^{-1}$, a value higher than that of very good electron acceptors such as halogenated hydrocarbons (e.g. $k = 3.0 \times 10^{10} \text{ M}^{-1} \text{ s}^{-1}$ for both CCl$_4$ and CHCl$_3$). Butadiene, which lacks conjugation with an aromatic ring, is less able to scavenge hydrated electrons ($k = 8.0 \times 10^{9} \text{ M}^{-1} \text{ s}^{-1}$) while benzene, as well as ethylene, can be both classified as unreactive ($k < 7.0 \times 10^{6} \text{ M}^{-1} \text{ s}^{-1}$). We therefore tentatively suggest that electron-trapping by an aromatic-conjugated acetylene like DEB may limit electron–hole recombination events by scavenging hydrated electrons. As a result, a larger number of surface holes become available to initiate monolayer formation.

To add strength to this argument we replaced DEB by an aliphatic $\omega,\omega$-dialkyne, 1,8-nonadiyne. As shown in Fig. 3 and Fig. S7 (ESI†) monolayer grafting of 1,8-nonadiyne is essentially
undetectable over the time scale that suffices for the same reaction of DEB/acetonitrile to reach completion. In contrast to DEB, 1,8-nonadiyne lacks conjugation with a π-electron system and we suggest that its inertness toward Si–H under mild dark conditions lies mainly in the poor electron-trapping ability of this aliphatic hydrocarbon.

There is however a number of other possible explanations we have considered. For example, the striking difference in reactivity between the DEB and 1,8-nonadiyne systems could be, in part, accounted for by the relative strength of cation–π interactions. Cation–π interactions are known to be significantly stronger in aromatic than in aliphatic compounds.43 In solution-phase systems, the solvent plays an important role toward the existence of silicon-based cations,44 and silylium ions (tricoordinate silicon atom, R₃Si⁺)45 are known to form adducts with aromatic compounds stable enough for isolation.46,47 However, silylium ions are strong electrophilic centres,48,49 and a strong N-donor like acetonitrile in solution chemistry is rapidly silylated at nitrogen by silylium ions.50 This route would result in a silylnitrilium ion. In our XPS measurements we specifically looked for any silyl nitrilium species, but the data for the DEB–acetonitrile system show no nitrogen signals (Fig. S4, ESI†). Our data, therefore, do not support this explanation.

We also considered a radical initiation step, possibly mediated by traces of oxygen,51 to account for the DEB high reactivity. The participation of oxygen would be in line with the solution-phase work of Zaborovskiy et al., who reported the spontaneous formation of silyl radicals by the reaction of tris(trimethylsilyl)silane (Me₃Si)₃Si–H with oxygen,52 and a parallel could also be made with the work of Chatgilialoglu et al., who observed that conjugation of the carbon–carbon triple bond with a π-system dramatically increases reaction rates for the radical hydrosilylation of 1-alkynes and 1-alkenes by molecular silanes.53 For example, rate constants for the addition at room temperature (ca. 300 K) of triethylsilyl radicals (Et₃Si⁺) to phenylacetylene (Ph–C≡CH), tert-butylacetylene (tBu–C≡CH), styrene (Ph–CH=CH₂) and tert-butylethylene (tBu–CH=CH₂) are 1.0 × 10⁶ M⁻¹ s⁻¹, 2.3 × 10⁶, 2.2 × 10⁶ M⁻¹ s⁻¹ and 3.7 × 10⁶ M⁻¹ s⁻¹. However, it is difficult to reconcile our results in the presence of radical species; silyl radicals do react rapidly with unsaturated compounds,53 but they are also very efficient in abstracting chloride from alkyl halides.54 That is, the addition reaction is in competition with Cl abstraction, and therefore, in the case of a radical initiating step caused by molecular oxygen contaminations, chlorine should be present on surfaces prepared from DEB solutions in DCM. Chlorine-related emissions are absent in XPS spectra, evidence pointing to radical initiation as an unlikely event.55 We also note that other groups have cast doubt on oxygen playing the role of a radical initiator in hydrosilylation reactions.12,56

It is very important to note that specific solvent–solute interactions may be more relevant in determining the efficiency of the electron-transfer (ET) than dielectric considerations on ET alone. For example, Mussell and Nocera reported cases of annihilation reactions where electron-transfer in DCM can occur at distances up to ~12 Å and with efficiencies higher than those measured in a highly-coordinating solvent like acetonitrile.57 Computation data by Johnson and DiLabio suggest that on a quite hydrophobic surface like the Si(100)–2 × 1 × 1 the separation between a benzene molecule and the surface is possibly as small as 4 Å.17 Given the likelihood of close proximity between the aromatic adsorbate and the hydrogenated silicon surface, the greater reactivity of DEB in acetonitrile is unlikely to be exclusively related to the effect of the high dielectric on the ET reaction.

An additional and simple explanation accounting for these very mild hydrosilylation conditions would be that the solvent-assisted rate enhancement does not correlate explicitly with the solvent’s dielectric constant but parallels the dipole moment and acid–base character of the solvent. With porous silicon (PSi), solvents with a large dipole moment may attract holes and electrons to the surface,58 with both nitrogen- and oxygen-containing solvents then efficiently trapping surface holes and quenching the PSi photoluminescence.59 To probe the relative effect of the solvent dielectric constant versus its dipole moment and acid–base character, experiments were run with THF as the DEB solvent. THF and DCM are very close in terms of dielectric constant and polarity (ε = 7.58, μ₃TC = 1.75, μDCM = 1.55), but in sharp contrast to DCM, as a result of Lewis acid–base stabilization of surface traps, THF can significantly reduce the rate of radiative recombination for h⁺–e⁻ pairs. In this case the h⁺–e⁻ pair that does not radiatively recombine can be...
solvent dielectric having a key role in defining the rate of \( \text{h}^+ / \text{e}^- \) recombination in PSi.\(^{61,62}\) In the case of a solvent-impregnated PSi matrix, solvents with a large dielectric constant have the greatest quenching effect on radiative \( \text{h}^+ / \text{e}^- \) recombination; this can be explained in terms of solvent-induced dielectric screening that limits the Onsager length (i.e., the \( \text{h}^+ / \text{e}^- \) distance at which Coulomb attractions equal \( kT \)). This effect reaches saturation at a dielectric value of approximately 20, with acetonitrile expected to have a stronger quenching effect on photoluminescence than DCM or THF.\(^{51}\) The speed of monolayer formation in the acetonitrile system therefore suggests that screening of Coulomb attraction between holes and electrons does play an important role under mild dark conditions.

It therefore seems unlikely that the solvent electron scavenging and/or dielectric factors on the ET between the active adsorbate and the substrate alone can govern the hydrolysislation by Si(100)–H at room temperature and in the dark. Under these very mild conditions it appears that the interplay between stabilization of surface traps and the electron-accepting properties of the adsorbate plays a more important role. If these factors are addressed, as shown in Fig. 1, the reaction progresses only marginally more rapidly in n-type Si, but it is still rather efficient on the p-type counterpart.\(^{63}\)

The mechanistic study above shows that monolayers can be formed on Si–H surfaces quickly without light excitation and from dilute systems of aromatic unactivated 1-alkynes. This is a mild strategy for the modification of n- and p-doped silicon by an organic layer, a capability of enormous technological interest.\(^{3}\) In this case we demonstrate the further utility of this chemistry by further functionalising the DEB-modified silicon surface.\(^{4}\) This is possible as the monolayer derived from DEB leaves a distal alkyne moiety, which is an excellent target for \textit{tagging} with organic azide through the archetypal “click” reaction, the copper-catalyzed alkyne–azide cycloaddition (CuAAC).\(^{19,21,27,64}\)

The electronic properties of the silicon substrate are easily tuned and a wealth of processes is available for the micro- and nano-patterning of this material; both these factors have been behind a remarkable research effort in trying to integrate redox-active molecules onto silicon electrodes.\(^{65}\) Ferrocene derivatives exhibit attractive electrochemical characteristics,\(^{66-68}\) and azidomethylferrocene\(^{69}\) was chosen here to demonstrate the functionalization of the DEB-passivated p-type Si(100) electrode. The ferrocene molecule has the dual role of (i) affording an insight into the charge transfer across the organic film as well as (ii) greatly simplifying the analytical task of assessing the outcome of CuAAC “click” reactions at the electrode surface (Scheme 1). Beginning with the latter, the Fe 2p\(_{3/2}\) and Fe 2p\(_{1/2}\) peaks, clearly visible at 708.4 and 721.4 eV in the high-resolution XPS spectrum (Fig. 4a), are consistent with values reported in the literature,\(^{68,69}\) and support the formation of the ferrocene layer. From the comparison of XPS- and stoichiometrically-derived Fe:N and N:(C–O/–N)\(^{70}\) atomic ratios it is possible to infer that the molecular nature of the ferrocene molecule is not appreciably altered upon its immobilization. C 1s and N 1s XPS data\(^ {19}\) (Fig. 4c and d) agree with the conversion of surface acetylene moieties to the putative surface CuAAC product, and the approximate fractional monolayer coverage of SiO\(_2\) varied from not detectable (\(<0.06\) to ca. 0.2 monolayer equivalents (Fig. 4d). The presence of silicon oxide signals in the 102–104 eV region of the XPS spectra is indicative of passivation of the semiconductor surface that is inferior to the one that can be achieved by thermal reactions of aliphatic 2,6-dialkynes.\(^{21}\) It is noteworthy, however, that despite the presence of silica contaminations the redox films exhibited remarkably stable cyclic voltammetric peaks,\(^ {71}\) attributable to the ferrocene/ferrocenium surface reaction, and surface coverage values, \( \Gamma \), that ranged from ca. 1.8 \( \times 10^{-11} \) to ca. 2.5 \( \times 10^{-11} \) mol cm\(^ {-2} \) (Fig. 5a). This coverage is in the range 40–56% of that expected for a hexagonally close-packed full monolayer of ferrocene molecules, assuming the molecule to be spherical with a diameter of 0.66 nm.\(^ {66}\)

Modular schemes offer considerable synthetic versatility but at the risk of multi-step chemistry leading to reduction of the electronic coupling between the redox element and the substrate. For this reason we measured the kinetics of the electrochemically-initiated ET between the electrode and the ferrocene moiety using electrochemical impedance spectroscopy (EIS).\(^ {72}\) Fig. 5b shows the Bode representations of the impedance data at either \( E_{dc} \sim E_0 \) in Fig. 5b or at \( E_{dc} \sim 0 \) V vs. reference in Fig. 5c (\( E_{dc} \), dc offset). For strongly adsorbed
Electroactive species the relationship between the circuit elements ($C_{dl}$, double-layer capacitance; $C_{ads}$, adsorption pseudo-capacitance; $R_{ct}$, charge transfer resistance) of and the kinetic parameters characterizing a redox system has been described in the literature. Using the refined $R_{ct}$ and $C_{ads}$ values, we obtained a $k_{ct}$ value of $8 \pm 2$ s$^{-1}$. This value indicates ET kinetics that are comparable to that of aliphatic films of comparable length.

At a sufficiently cathodic applied dc potential ($E_{dc} = 0$ V, Fig. 5c), the phase angle of the Bode plots adopts a sigmoidal shape that starts near 0° at high frequency and shifts close to 90° at frequencies of $<100$ Hz. An ideal series RC circuit would have the lower-frequency points at 90° because the response is dominated by the double-layer capacitance charging. The EIS data thus suggest a blocking or insulating monolayer that can be modelled using a circuit that does not model a charge-transfer reaction but describes a polarizing electrode (i.e., with two terms $R_s$ and $C_{dl}$ in series).

**Conclusions**

Our experimental observations point to a strategy to overcome the generally higher reactivity of n-type semiconductor Si surfaces toward attack by nucleophilic adsorbrates, and expand the available repertoire of mild wet chemistry routes to functional surfaces.

All non-oxide semiconductors are susceptible to anodic degradation and the DEB passivation of the Si(100) electrode as achieved by dark and room temperature hydrosilylation reactions remains poor when compared to alternative grafting methods. However, we believe the exceedingly mild monolayer-forming conditions reported in this paper are remarkable and will stimulate further experimental scrutiny. Notably, films incorporating phenyl rings and bi-functional contacts also hold considerable advantages when making top contacts in molecular devices.

**Notes and references**

carbons for the reactions of acetylenes and hydrogenated silicon surfaces is found in ref. 34.

71 In aqueous environments the decrease in \( \Gamma \) values was less than 8% after 100 CV cycles (Fig. 5a).


73 Both \( C_{\text{dl}} \) and \( C_{\text{ads}} \) showed a frequency-dependent capacitive behavior and were therefore treated as constant-phase elements (CPEs), a mathematical formalism used to model an imperfect capacitor in an electrical circuit. For a CPE the impedance is equal to \( 1/Q (j\omega)^{\phi} \), in which \( \omega \) is the angular frequency, \( Q \) is a parameter with the units of \( \text{V} \cdot \text{cm}^{-2} \cdot \text{s} \), and \( \phi \) is an exponential term with values between 0 and 1. CPE defines inhomogeneity in the electrochemical system.


79 It is important to note that attempts to compare rates constants for the electron-transfer of chemically distinct redox constructs is not trivial and has to take into account several factors. For example, variations in electrode kinetics may be associated with (i) the length and nature of the electron-transfer bridge and with the properties/concentration of the any diluent molecule in the SAM see P. K. Eggers, D. B. Hibbert, M. N. Paddon-Row and J. J. Gooding, J. Phys. Chem. C, 2009, 113, 8964–8971, and (ii) with either space-charge effects at the monolayer/solvent interface or changes in adsorption geometry induced by SAM dilution/concentration or both, see K. M. Roth, A. A. Yasseri, Z. Liu, R. B. Dabke, V. Malinovskii, K.-H. Schweikart, L. Yu, H. Tiznado, F. Zaera, J. S. Lindsey, W. G. Kuhr and D. F. Bocian, J. Am. Chem. Soc., 2003, 125, 505–517.

80 Curve fitting results in an interfacial capacity, \( C_{\text{dl}} \), of ca. 3.8 \( \mu \)F cm\(^{-2} \) (\( \phi = 0.99 \)). The value of Helmholtz capacitance for both hydrogen-terminated and monolayer-modified silicon electrodes is generally found to be lower than for metal electrodes E. J. Faber, W. Sparreboom, W. Groeneveld, L. C. P. M. de Smet, J. Bomer, W. Olthuis, H. Zuilhof, E. J. R. Sudhölter, P. Bergyeld and A. van den Berg, \( \text{pH} \) Sensitivity of Si-C Linked Organic Monolayers on Crystalline Silicon Surfaces, ChemPhysChem, 2007, 8, 101–112.